35.C13319



## PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

MASATAKA YAMASHITA, ET AL.

Application No.: 09/250,400 

Filed: February 16, 1999

For: METHODS FOR PRODUCING

ELECTRON-EMITTING

DEVICE, ELECTRON SOURCE,

AND IMAGE-FORMING
APPARATUS

Examiner: Unassigned

Group Art Unit: 2875

Fully 26, 1999

RECEIVED

Publishing Division

Assistant Commissioner for Patents Washington, D.C. 20231

DEC 07 1999

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# SECOND INFORMATION DISCLOSURE STATEMENT TECH 4

Sir:

In compliance with the duty of disclosure under

37 C.F.R. § 1.56 and in accordance with the practice under

37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are enclosed.

The Examiner's attention is also directed to the following U.S. Applications:

APPLN. NO.	FILING DATE	GROUP ART UNIT	<u>STATUS</u>
09/300,846	28 APR 1999	2812	Pending
09/292,014	15 APR 1999	2875	Pending
09/255,841	23 FEB 1999	2852	Pending
09/178,680	26 OCT 1998	2875	Pending

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APPLN. NO.	FILING DATE	GROUP ART UNIT	<u>STATUS</u>
08/961,223	30 OCT 1997	1762	Pending
08/781,206	10 JAN 1997	2875	Pending

U.S. Application No. 08/961,223 is a continuation application of Application No. 08/359,746, now abandoned.

In accordance with 37 C.F.R. § 1.98(a)(2)(iii), no copy of any cited U.S. Application is enclosed.

### FEE STATEMENT

Since the present Information Disclosure Statement is being submitted prior to the mailing of a first Office Action on the merits, no fee is believed due. Nevertheless, the Commissioner is authorized to charge any fee required in connection with this paper to Deposit Account 06-1205. A duplicate of this paper is enclosed for that purpose.

#### REMARKS

A concise explanation of relevance for the Japanese Patent Applications can be found on pages 4 and 5 of the specification and/or in the corresponding, attached English Abstracts.

A concise explanation of relevance for the <u>Hisashi</u>

<u>Araki et al. document</u> ("Electroforming and Electron Emission of Carbon Thin Films") can be found on page 2 of the

specification and/or in the corresponding, attached English Abstract.

English translations of these Japanese documents are not readily available to Applicants' attorney, but may provided if required by the Examiner.

### CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned, indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Washington office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

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